

35.C11969 REI



PATENT APPLICATION

1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of: : Previous
NOBUMASA SUZUKI :) Examiner: L. Alejandro
:)
Appln. No.: 09/657,971 :)
:) Group Art Unit: 1763
Filed: September 8, 2000 :)
:)
Patent No.: 5,803,975 :)
Issued: September 8, 1998 :)
:)
For: MICROWAVE PLASMA :)
PROCESSING APPARATUS :)
AND METHOD THEREFOR :) January 17, 2001

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BOX REISSUE
Commissioner for Patents
Washington, D.C. 20231

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The enclosed documents are certified translations
of JP-5-44798, JP 5-62796 and JP 7-263186. Non-certified
copies of these documents were previously provided with the
Information Disclosure Statement dated September 7, 2000.

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CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicant

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